



JPW

Docket No.: 1572.1243

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Je-Hyoung RYU, et al.

Serial No. 10/820,748

Group Art Unit: 2829

Confirmation No. 8797

Filed: April 9, 2004

Examiner: Vinh P. Nguyen

For: INSPECTING APPARATUS HAVING A RADIATOR TO RADIATE HEAT FROM A SEMICONDUCTOR DEVICE

RESPONSE TO NOTICE REGARDING DRAWINGS

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Notice Regarding Drawings mailed January 19, 2006, wherein the USPTO required that corrected Figure 6 be filed to overcome the objection in the draftperson's drawing review. The following replacement Sheet of Figure 6 is respectfully resubmitted.

It is respectfully requested that the corrected formal drawing filed herewith be entered in the above-referenced application.

Respectfully submitted,

STAAS & HALSEY LLP

Date: *March 6, 2006*

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